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Applicant : Jeffrey Drue David  
Serial No. : 10/643,583  
Filed : August 18, 2003

Art Unit : 3723  
Examiner : Maurina T. Rachuba


Title : PLATEN AND HEAD ROTATION RATES FOR MONITORING CHEMICAL  
MECHANICAL POLISHING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Attached to this facsimile communication cover sheet is Amendment After Allowance  
Pursuant to 37 C.F.R. §1.312 and Comments on Statement of Reasons for Allowance, faxed this  
12<sup>th</sup> day of October, 2005, to the United States Patent and Trademark Office.

Respectfully submitted,

Date: October 12, 2005

  
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